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Applicant(s): Cline et al.

Docket No.

BUR920040122US1

Application No.

10/711,953

Filing Date

10/15/2004

Examiner

Chen, Eric Brice

Group Art Unit

1765

Invention: **DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION**

I hereby certify that this _____ Request for Reconsideration (12 pages)

(Identify type of correspondence)

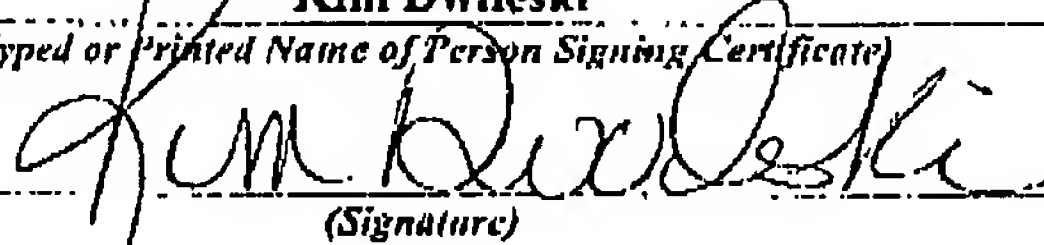
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cline *et al.*

Examiner: Chen, Eric Brice

Serial No.: 10/711,953

Art Unit: 1765

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Docket No.: BUR920040122US1

Title: **DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

Sir:

This Request for Reconsideration is in response to the Final Office Action mailed
January 26, 2006.

10/711,953

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